



IFW

Attorney Docket No. 5051-538DV2

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Phillip E. Russell et al.

Confirmation No. 7098

Application No.: 10/672,091

Group Art Unit: 2881

Filed: September 26, 2003

Examiner: Johnnie L. Smith

For: Chemically Enhanced Focused Ion Beam Micro-Machining of Copper

Date : December 8, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO
OFFICE ACTION DATED SEPTEMBER 8, 2004**

Sir:

Responsive to the Office Action dated September 8, 2004, please amend the above-identified application as shown.

If any extension of time for the accompanying response or submission is required, Applicant requests that this be considered a petition therefor. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

Amendments to the Claims are reflected in the Listing of Claims, which begins on page 2 below.

Remarks begin on page 4 below.